

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Andreas Meckes et al.  
Filed: Herewith  
Title: ELECTRONIC COMPONENT AND METHOD FOR ITS PRODUCTION  
Docket No.: I431.101.101 (2002P15009US)

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**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

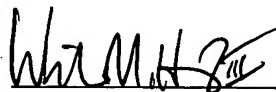
Sir:

Pursuant to 37 C.F.R. § 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. One copy of each Foreign and Other Reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date. No certification or fee is required.

Customer No. 025281  
DICKE, BILLIG & CZAJA, PLLC  
Fifth Street Towers, Suite 2250  
100 South Fifth Street  
Minneapolis, MN 55402  
Telephone: (612) 573-2010  
Facsimile: (612) 573-2005

Respectfully submitted,

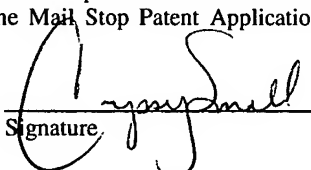


William M. Hienz III  
Reg. No. 37,069

**CERTIFICATE OF EXPRESS MAIL**

"Express Mail" mailing label number EV409552537US, Date of Deposit: November 26, 2003. I hereby certify that this paper is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. § 1.10 on the date indicated above and is addressed to the Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cryssy Small  
Name of Person Signing



Signature

<b>FORM PTO-1449 MODIFIED</b>  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>				Docket No.: I431.101.101 (2002P15009US)		Application No.: Unknown	
				APPLICANT: Andreas Meckes et al.  FILING DATE: Herewith  GROUP ART UNIT: Unknown			
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	4,744,863	05-1988	Guckel et al.				
	5,090,254	02-1992	Guckel et al.				
	5,454,906	10-1995	Baker et al.				
	5,872,493	02-1999	Ella				
	6,114,635	09-2000	Lakin et al.				
	6,232,150	05-2001	Lin et al.				
	2001/0001293	05-2001	Gotoh et al.				
	2001/0004085	06-2001	Gueissaz				
	6,550,664	04-2003	Bradley et al.				
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER INITIAL	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES      NO	
	101 05 351 A 1	08-2002	DE				X
<b>OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)</b>							
	Mei et al., "Process Characterization and Analysis of Sealed Vacuum Microelectric Devices," J. Vac. Sci. Techn. B 12(2), March/April 1994, pp. 638-643.						
	Hakan Ederstig, Per Wallgren, "Spin Desposition of Polymers over Holes and Cavities," Sensors and Actuators A46-47, 1995, pp. 95-97.						
EXAMINER SIGNATURE			DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							